

Attorney Docket: 025403-0307457  
Client Reference: OG03-027

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:  
**BYEONG RYEOL LEE**

Confirmation Number: 2865

Application No.: 10/747,621

Group Art Unit: 2823

Filed: December 30, 2003

Examiner: JEFFERSON, Quovaunda

Title: METHOD OF FORMING ISOLATION STRUCTURES IN EMBEDDED  
SEMICONDUCTOR DEVICE

**AMENDMENT WITH REQUEST FOR CONTINUED EXAMINATION  
UNDER 37 C.F.R. §1.114**

**Mail Stop RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action date February 15, 2007, prior to continued examination,  
please amend the above-identified application as follows: